

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE - EXAMINING GROUP 2810**

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Gabriele Barlocchi et al.  
Application No. : 10/667,113  
Filed : September 18, 2003  
For : METHOD FOR FORMING HORIZONTAL BURIED CHANNELS  
OR CAVITIES IN WAFERS OF MONOCRYSTALLINE  
SEMICONDUCTOR MATERIAL

Examiner : Fazli Erdem  
Art Unit : 2826  
Docket No. : 854063.552D1  
Date : May 4, 2009

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE/AMENDMENT UNDER 37 CFR 1.116**

Commissioner for Patents:

In response to the Office Action dated February 5, 2009, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.